

Docket No. HVD2105

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

10/695,381

Confirmation No.: 5308

Applicants:

Jene A. Golovchenko et al.

Filed:

October 28, 2003

TC/A.U.:

1753

Examiner:

S. H. Versteeg

Docket No.:

HVD2105

For:

Pulsed Ion Beam Control of Solid State

Features

MAIL STOP RCE

COMMISSIONER FOR PATENTS

P.O. Box 1450

ALEXANDRIA, VIRGINIA 22313-1450

I hereby certify that this correspondence is

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PETITION FOR THREE -MONTH EXTENSION OF TIME UNDER 37 C.F.R. 1.136(a)

Beura X

Hereby is petitioned the Commissioner for Patents to extend, for the patent application referenced above, the deadline for response to the Examiner's Action mailed October 4, 2005, for THREE (3) months, extending the last day of the response period from December 4, 2005, up to and including March 6, 2006. A reply is filed herewith.

Enclosed is a check including the amount of \$1020.00 for the extension fee under 1.17(a)(3).

Please apply any deficiency in the stated fee and any other required fees, and please apply any overpayment, to <u>Deposit Account No. 12-1760</u>.

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Respectfully submitted,

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